



Attorney Docket No.: VLSI-2759

GP3724

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
Patent Application

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In re Application

Inventor(s): Charles Franklin Drill and Milind Weling

Application No.: 08/824,633

Filed: 03/27/97

Title: A CUSTOMIZED POLISHING PAD FOR SELECTIVE PROCESS PERFORMANCE DURING CHEMICAL MECHANICAL POLISHING

Assistant Commissioner for Patents
Washington, D.C. 20231

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NOTIFICATION OF FILING OF CONTINUING APPLICATION

 Notification is hereby being made of the filing of an CPA application for this case concurrently herewith.
 on

Please direct all correspondence concerning the above-identified application to the following address:

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Respectfully submitted,

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Date: November 22, 1999